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PATENT
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Gonzalez et al

Group Art Unit: 2815

SEMICONDUCTOR RAISED
SOURCE-DRAIN STRUCTURE

Examiner:

Serial No. 10/008,653

Filed: November 9, 2001

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INFORMATION DISCLOSURE STATEMENT

January 11, 2002

Commissioner for Patents
Washington, DC 20231

Sir:

Applicants, in accordance with their duty of disclosure pursuant to 37 C.F.R. § 1.56, hereby advise the United States Patent and Trademark Office of the references listed on the accompanying form PTO-1449 *Information Disclosure Statement by Applicant*. A copy of each of the references cited therein is herewith enclosed.

Applicants note that although the cited references may be relevant to the examination of the above-referenced application, under 37 C.F.R. § 1.97(h), the filing of

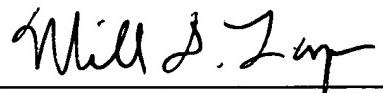
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this *Information Disclosure Statement* by Applicant "shall not be construed to be an admission that the information cited in the statement is, or is considered to be, material to patentability as defined in § 1.56(b)."

Respectfully submitted,



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